



Attorney Docket # 2007-83

AP
JFW
MS-AF

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Wilhelm STEIN et al.

Serial No.: 10/789,199

Filed: February 26, 2004

For: Electrical Contact for Optoelectronic
Semiconductor Chip and Method for its
Production

Examiner: LOUIE, Wai Sing
Group Art: 2814

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

July 6, 2006

(Date of Deposit)

Thomas Langer

Name of applicant, assignee or Registered Representative

Thomas Langer
Signature

July 6, 2006

Date of Signature

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

SIR:

In response to the Final Office Action dated April 6, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.